

September 30, 2019

To the ANS Student Conference Selection Committee,

As their faculty advisor, I enthusiastically support the University of Illinois ANS student section bid to host the 2021 ANS Student Conference.

The Illinois ANS Student Section is the most vibrant and active student section I have encountered and I have complete confidence in their capability to organize and execute an exceptional and successful student conference. Notably, this student chapter has an extraordinary membership which devotes enormous time and effort to nuclear advocacy and national involvement. The vibrance and drive of this student section has accordingly been consistently recognized with the Glasstone Award in 2016 (Best Section), 2017 (Honorable Mention), 2018 (Honorable Mention), and 2019 (3rd Place). Also, this student section enjoys strong departmental support from the Department of Nuclear, Plasma, and Radiological Engineering which will certainly help to ensure the success of this conference.

Additionally, this chapter has demonstrated their enthusiasm for the student conference through their attendance and performance at those hosted elsewhere. In recent years, 30-40 Illinois students typically attend the ANS student conferences where these Illinois attendees present research and receive awards accordingly.

Finally, 2020 will be an exciting time for students from around the country to be introduced to the Nuclear, Plasma, and Radiological Engineering Department at the University of Illinois. The department has undergone a period of exceptional growth, and now boasts a youthful, vibrant faculty. The resulting expansion of our research efforts and experimental facilities will provide a fresh take on nuclear, plasma, and radiological engineering today.

It is with high hopes that I write this letter of support for the UIUC student section proposal to host the student conference. I hope you will not hesitate to ask if you have any questions regarding my support.

Sincere regards,



Kathryn Huff
Assistant Professor
Nuclear, Plasma, & Radiological Eng.
U. Illinois at Urbana-Champaign